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The invention relates to electronics, in particular to a process for coaxial microwire obtaining.

The process for coaxial microwire obtaining includes the preliminary manufacture of the blank, heating thereof in the process of pulling through the resistance furnace and formation of microwire. The blank contains two coaxially placed vacuum-treated glass ampoules, the annular space between which and the cavity of the interior ampoule are filled with charges of metallic or semimetallic, or semiconductor material. The charges, placed into the annular space between the ampoules and into the cavity of the interior ampoule, may be of different materials.

Claims: 1

Fig.: 2